

<b>Notice of References Cited</b>	Application/Control No. 10/603,023	Applicant(s)/Patent Under Reexamination WEYDERT ET AL.	
	Examiner Mei Q. Huang	Art Unit 1713	Page 1 of 1

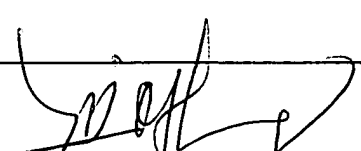
**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,617,383	09-2003	Ikawa et al.	524/167
*	B	US-6,695,734	02-2004	Hedberg et al.	474/263
*	C	US-6,464,607	10-2002	Rosenboom et al.	474/263
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	KR2003037142A ✓	11-2001	KR	Kim et al.	
	O	JP10087888A	09-1996	JP	Fukutomi	
	P	JP411323023A	05-1998	JP	Nohara	
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	 <span style="float: right;">Dec. 3, 2004</span>

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.